

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In Re Patent Application of:

Mark N. Kawaguchi, et al.

Application No.: 09/978,121

Filed: October 15, 2001

For: A METHOD OF PHOTORESIST
REMOVAL IN THE PRESENCE
OF A DIELECTRIC LAYER
HAVING A LOW K-VALUE

Examiner: Not Yet Assigned

Art Unit: 1733

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATEMENT UNDER 37 C.F.R. § 1.97(e)

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I hereby certify (as indicated by an "X" to the left of the appropriate paragraph):

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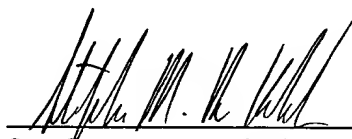
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Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: May 14, 2003



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